40006317-0097-002

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INFORMATION DISCLOSURE
STATEMENT BY APPLICANT
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Complete if Known

Application Number Not Yet Received

Filing Date December 10, 2004

First Named Inventor Aviram Tam

Art Unit Not Yet Received

Examiner Name

Attorney Docket Number

Sheet 1

U. S. PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant	
	<u> </u>	Number-Kind Code ^{2 (# known)}			Figures Appear	
		^{US-} 6,480,807 B1	11/12/2004	Miyano Yumiko		
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FOREIGN PATENT DOCUMENTS								
Examiner Initials*	Cite No.1	Foreign Patent Document	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages	Τ		
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	ļ	EP 1 279 923 A	01/29/2003	Hitachi, Ltd.				
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		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		APPLIED MATERIALS ISRAEL, LTD, International Search Report and Written Opinion, PCT/US2004/041884, 27 April 2005, pp	
		LEE TAE YONG ET AL.: "Experimental methodology of contact edge roughness on sub-100 nm pattern", Proceedings of SPIE: 24 May 2004, 10 pp	
		BUNDAY BENJAMIN D ET AL.: "CD-SEM Measurement of Line Edge Roughness Test Patterns for 193 nm Lithography", Proceedings of SPIE: July 2003, 15 pp	

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